**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of

Shunpei YAMAZAKI et al.

Serial No.: 08/691,434

Filed: August 2, 1996

For: METHOD OF FABRICATING

SEMICONDUCTOR DEVICES

AND APPARATUS FOR

PROCESSING A SEMICONDUCTOR )

ATTN: REFUND DIVISION

Group Art Unit: 1107

Examiner: M. Wilczewski

FECEIVED J. mcmillan
SEP 1 8 1998 2/12/99

GROUP 2100

REQUEST FOR REF

**Assistant Commissioner for Patents** Washington, D. C. 20231

Sir:

Applicants respectfully request a refund in the amount of \$240.00. On August 10, 1998, an Information Disclosure Statement was filed along with our check for \$240.00 (#62222). The references submitted with that Information Disclosure Statement, however, were cited in a related Korean application on June 30, 1998. Since the references submitted with the Information Disclosure Statement were cited in a related application within three months of submitting same to the U.S. Patent and Trademark Office, no fee is required. 37 C.F.R. §1.97(e). A copy of the Certification under 37 C.F.R. §1.97(e) filed contemporaneously herewith is attached hereto for the convenience of the U.S. PTO. In view of the foregoing, Applicants respectfully request a refund in the amount of \$240.00.

Application No. 08/691,434 Attorney Docket No. 0756-1551



The Commissioner is hereby authorized to credit this overpayment to Deposit Account No.

2-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,

SIXBEY, FRIEDMAN, LEEDOM & FERGUSON, P.C.

Date

Lawrence D. Eisen Registration No. 41,009

GJF/EJR/LDE/kmj

Attorney Docket No.: <u>0756-1551</u>

SIXBEY, FRIEDMAN, LEEDOM & FERGUSON, P.C. 2010 Corporate Ridge, Suite 600 McLean, Virginia 22102 Telephone (703) 790-9110

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| Serial No.: 08/691,434  | Examiner: M. Wilczewski |
| Filen August 2, 1996  | }                       |
| File August 2, 1996  METHOD OF FABRICATING SEMICONDUCTOR DEVICES AND APPARATUS FOR PROCESSING A SEMICONDUCTOR |                         |

## **CERTIFICATION UNDER 37 C.F.R. §1.97(e)**

**Assistant Commissioner for Patents** Washington, D. C. 20231

Sir:

[X] Each item of information contained in the Information Disclosure Statement filed August 10, 1998 was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of that Information Disclosure Statement.

OR

No item of information in the Information Disclosure Statement filed herewith was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,

SIXBEY, FRIEDMAN, LEEDOM & FERGUSON, P.C.

Date

Lawrence D. Eisen

Registration No. 41,009

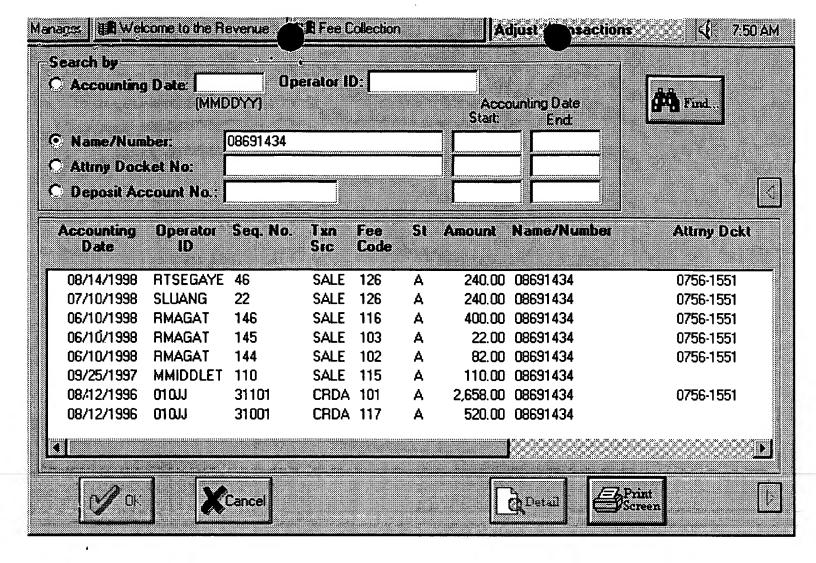
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Adjustment date: 09/08/1998 DHARRIGA 07/10/1998 SLUANG 00000021 192380 08691434 01 FC:126 240.00 CR